



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of)
MAEDA et al) Art Unit: 2829
Serial No.: 09/808,016) Examiner: Kilday
Filed: March 15, 2001)
For: FILM-FORMING SURFACE)
REFORMING METHOD AND)
SEMICONDUCTOR DEVICE)
MANUFACTURING METHOD)

2829
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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(d)

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

It is respectfully requested that the examiner consider and cite of record the four references listed on the attached, copies of which are submitted herewith. Also submitted herewith is a copy of a European Search Report dated December 13, 2002, by which the documents submitted here were brought to applicants' attention. The fifth document listed in the European Search Report, i.e., EP 1058301, has previously been made of record here.

The fee required by 37 CFR 1.17(p) is submitted herewith. See the attached credit card payment form.

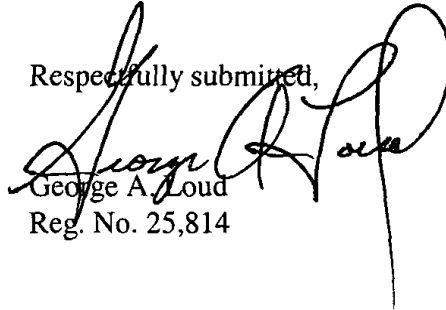
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Each item of information submitted here was first cited in any communication from a foreign patent office in a counterpart application not more than three months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,



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Dated: March 4, 2003

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